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Table of Contents

<i>Preface</i>	<i>iii</i>
Investigation of a New Conditioning Method for Improved Performance of Non-Nernstian Sensors <i>P. Sekhar, E. Brosha, R. Mukundan, B. Farber, P. Shuk, and F. H. Garzon</i>	1
Sensors Based on Electrochemically Deposited Titania Studied by AFM and EIS Techniques <i>M. Sánchez, C. Cuevas, and M. E. Rincón</i>	9
Cobalt Doped $\text{Sm}_{0.95}\text{Ce}_{0.05}\text{FeO}_{3-\delta}$ for Detection of Reducing Gases <i>S. M. Bukhari and J. B. Giorgi</i>	19
Development of Thermal Conductivity Type Hydrogen Sensor <i>M. Watanabe, R. Inoue, D. Ichikawa, and K. Furusaki</i>	31
Resonance Elastic Light Scattering and Plasmonic Phenomena in Glutathione-Mediated Gold Nanoparticle Assembly <i>Z. Reed, A. Prance, M. Stobiecka, and M. Hepel</i>	43
A Model for Mechanical Force Sensing in Conducting Polymers <i>T. Mirfakhrai, T. Shoa, N. Fekri, and J. Madden</i>	59
Towards Printable Open-Air Microfluidic Devices <i>A. D. Collord, E. Branson, K. Fenton, A. W. Cook, P. Clem, and C. Apblett</i>	73
Development, Optimization and Evaluation of a CF_4 Pretreatment Process to Remove Unwanted Interfacial Layers in Stacks of CVD and PECVD Polycrystalline Silicon-Germanium for MEMS Applications <i>G. Bryce, S. Severi, R. van Hoof, B. Guo, E. Kunnen, A. Witvrouw, and S. Decoutere</i>	79

Comparison between Nafion and Polybenzimidazole (PBI) Membranes for Fuel Cell Type CO Sensor <i>K. Mochizuki, T. Kikuchi, M. Sudoh, Y. Ishiguro, and T. Suzuki</i>	91
Author Index	101